

INTERNATIONAL  
GEMOLOGICAL  
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

November 8, 2024

IGI Report Number

LG662489550

Description

LABORATORY GROWN DIAMOND

Shape and Cutting Style

EMERALD CUT

Measurements

7.79 X 5.49 X 3.76 MM

GRADING RESULTS

Carat Weight

1.57 CARAT

Color Grade

D

Clarity Grade

VS 2

ADDITIONAL GRADING INFORMATION

Polish

EXCELLENT


Symmetry

EXCELLENT

Fluorescence

NONE

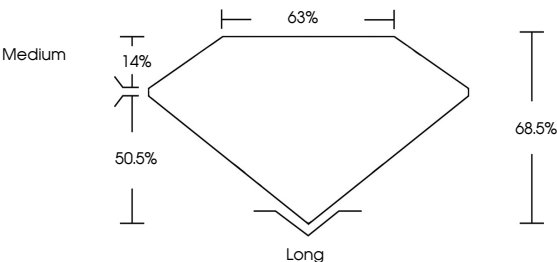
Inscription(s)

 LG662489550

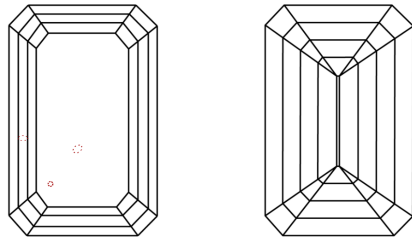
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa

Report verification at igi.org

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

Sample Image Used

COLOR


D E F G H I J Faint Very Light Light

CLARITY

IF VS 1-2 VS 1-2 SI 1-2 I 1-3

Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included

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
Symmetry

EXCELLENT

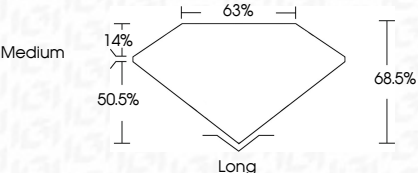
Fluorescence



NONE

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IGI

November 8, 2024

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EMERALD CUT

7.79 X 5.49 X 3.76 MM

Carat Weight

1.57 CARAT

Color Grade

D

Clarity Grade

VS 2

Depth

50.5%

Table

14%

Girdle

Medium

Culet

Long

Polish

EXCELLENT


Symmetry

EXCELLENT

Fluorescence

NONE

Inscription(s)

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Type IIa